IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Brian W. Baird, Michael J. Wolfe,
Richard S. Harris, Kevin P. Fahey,
Lian-Cheng Zou, and Thomas R. McNeil

Group Art Unit: 1732

Application No. 10/017,497

Filed: December 14, 2001

For: ULTRAVIOLET LASER ABLATIVE PATTERNING
OF MICROSTRUCTURES IN SEMICONDUCTORS

Examiner:

Date: December 6, 2002

TRANSMITTAL LETTER

TO THE COMMISSIONER FOR PATENTS:

Enclosed for filing in the above-referenced application are the following:
[X]   Information Disclosure Statement, and
[X]   PTO-1449 (with a copy of each of the cited references)

The Commissioner is hereby authorized to charge any fees which may be required in connection with filing of these papers, or credit overpayment, to Account No. 19-4455. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

Brian W. Baird, Michael J. Wolfe,
Richard S. Harris, Kevin P. Fahey,
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Inventors: Brian W. Baird, Michael J. Wolfe,
Richard S. Harris, Kevin P. Fahey,
Lian-Cheng Zou, and Thomas R. McNeil

Title: **ULTRAVIOLET LASER ABLATIVE PATTERNING
OF MICROSTRUCTURES IN SEMICONDUCTORS**

Attorney Docket No.: 50001/83:2 USA

CERTIFICATE OF FIRST-CLASS MAILING

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Signature

Lois M. Rosenbladt
Typed or printed name of person signing certificate

Attachments:

✔ Transmittal Letter (in duplicate)
✔ Information Disclosure Statement
✔ Form PTO-1449, with copies of cited references
✔ Return-Receipt Postcard